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Attorney Docket No. 0756-2077

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 09/466,828

Filed: December 20, 1999

For: INSULATING FILM AND METHOD
OF PRODUCING SEMICONDUCTOR
DEVICE

) Group Art Unit: 2818

) Examiner: R. Berry

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is
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Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on October 17,
2005.

) Adeline M. Stampen

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated June 20, 2005, please consider the
following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 3 of this paper.

Remarks begin on page 9 of this paper.

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04 FC:1202 300.00 OP